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APPLICANTS

Yong-Kyun Ko, Osan-city, KOREA, REPUBLIC OF;
 Byung-Woo Son, Yongin-city, KOREA, REPUBLIC OF;
 Jong-Cheol Jeong, Gyeonggi-do, KOREA, REPUBLIC OF;

** CONTINUING DATA *****
None ZE

** FOREIGN APPLICATIONS *****
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ZE

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>ZE</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 14	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
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ADDRESS
 LEE & STERBA, P.C.
 Suite 2000
 1101 Wilson Boulevard
 Arlington, VA
 22209

TITLE
 Apparatus and method for collecting impurities on a semiconductor wafer

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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